

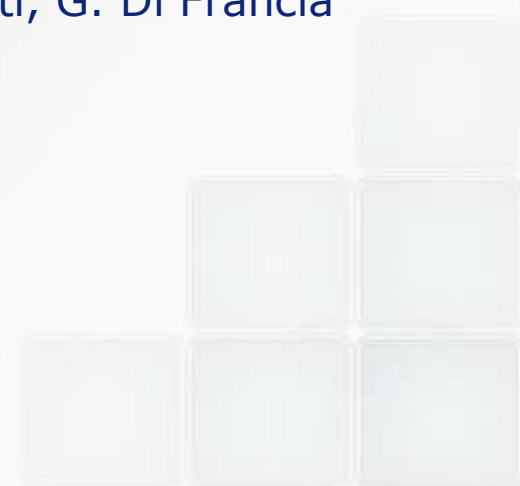


# **Focused Ion Beam electrode patterning for nanostructured material-based chemical gas sensor**

**Vera La Ferrara**

and B. Alfano, G. Fiorentino, M. Miglietta, E. Massera, T. Polichetti, G. Di Francia

**EFUG MEETING 2010**  
**Gaeta, October 11**



# ENEA Research Centre in Portici



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# Nanotechnology Laboratory: Facilities in Portici



Clean room for photolithographic process



Surface area and pore analyzer

Dynamic Light Scattering



Dual Beam FEI QUANTA 200 3D  
(SEM and Focused Ion Beam)



Optical and electrical apparatus for  
sensor testing





## FOCUSED ION BEAM

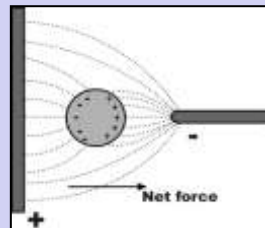
geometry of the electrodes plays a very important part

Finely focused beam of gallium ion interacts with metallorganic compounds and deposit metal nanoelectrodes

&

## DIELECTROPHORESIS

non-uniform electric field polarizes small particles, in solution, moving to high electric field up to assemble nanowires



**NO TEMPLATE**

•GROWTH

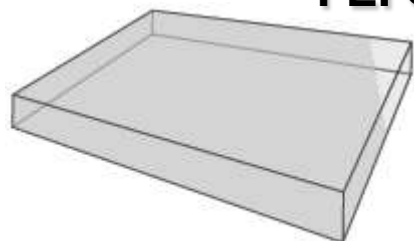
•POSITION

•ALIGN

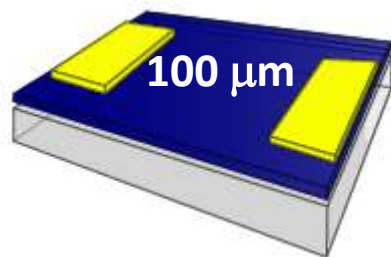
•NO MANIPULATION

# FIB-assisted platinum electrodes & Dielectrophoresis

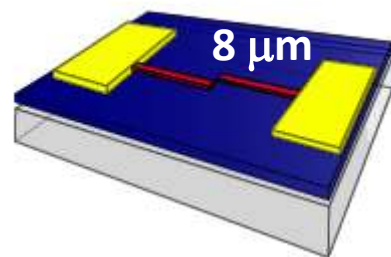
## FEI QUANTA 200 3D



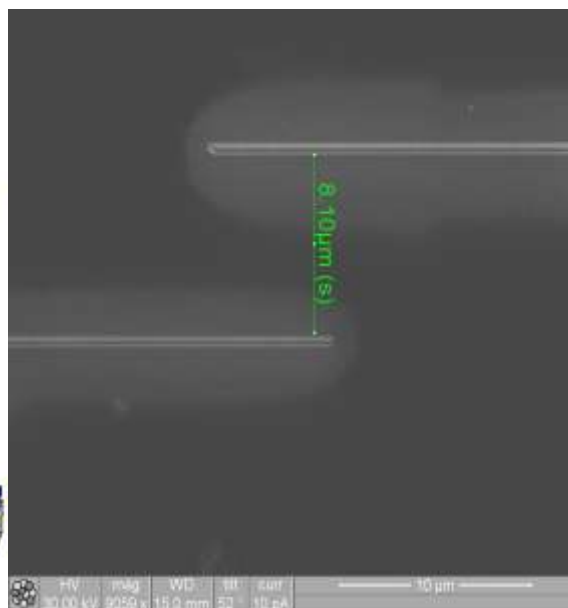
Silicon substrate



100  $\mu\text{m}$



8  $\mu\text{m}$

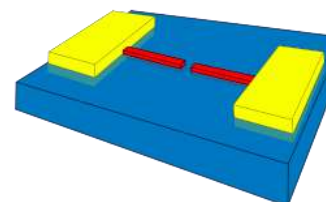
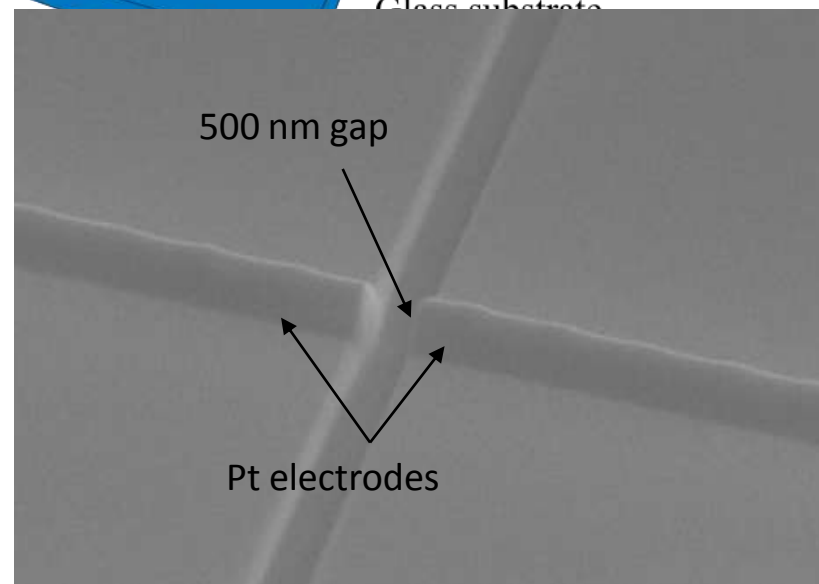


8  $\mu\text{m}$  gap

**Platinum microelectrodes**  
(300 nm in width, 500 nm in height)  
deposited by  
**FOCUSED ION BEAM (FIB)**



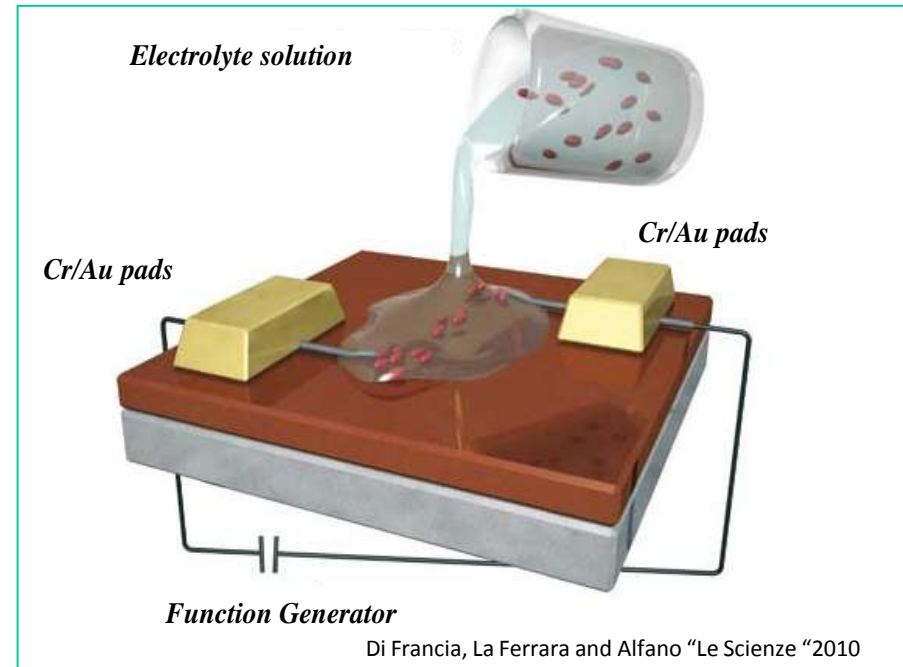
Glass substrate



Gap milling by FIB  
500 nm

## ELECTROLYTE SOLUTIONS

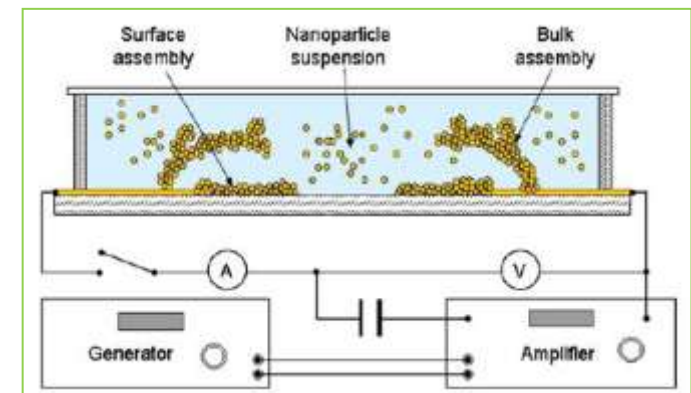
1. Palladium acetate solution
2. ZnO in DIW solution
3. graphite dispersion in N-Methyl Pyrrolidone and exfoliation in graphene

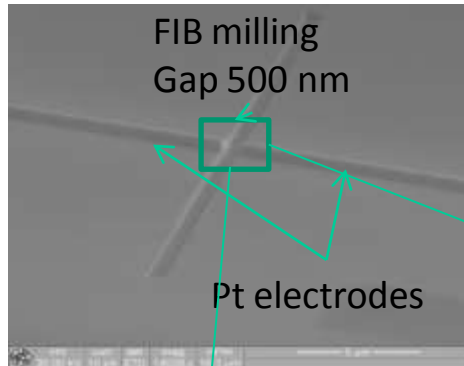


$$\langle \vec{F}_{DEP} \rangle = 2\pi\epsilon_m \operatorname{Re}[K(\omega)] R^3 \nabla |\vec{E}|^2$$

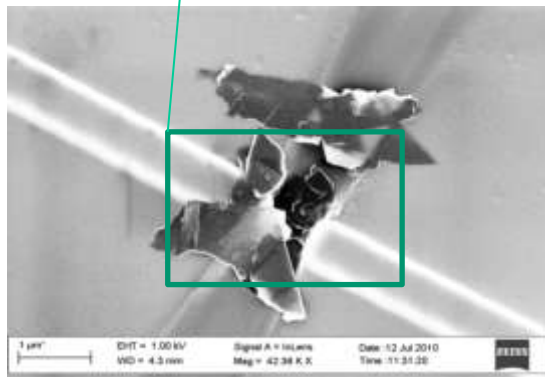
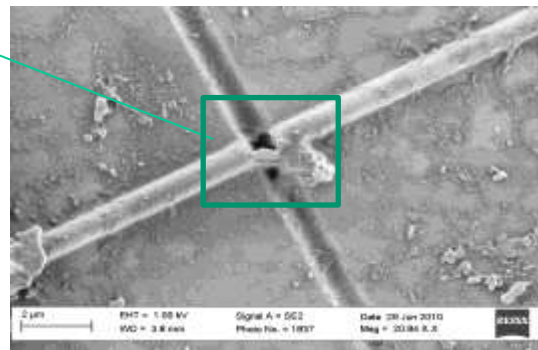
**Clausius-Mossotti Factor**

$$\operatorname{Re}[K(\omega)] = \frac{\epsilon_p - \epsilon_m}{\epsilon_p + 2\epsilon_m} + \frac{3(\epsilon_m \sigma_p - \epsilon_p \sigma_m)}{\tau_{MW} (\sigma_p + 2\sigma_m)^2 (1 + \omega^2 \tau_{MW}^2)}$$





## Graphene-based devices

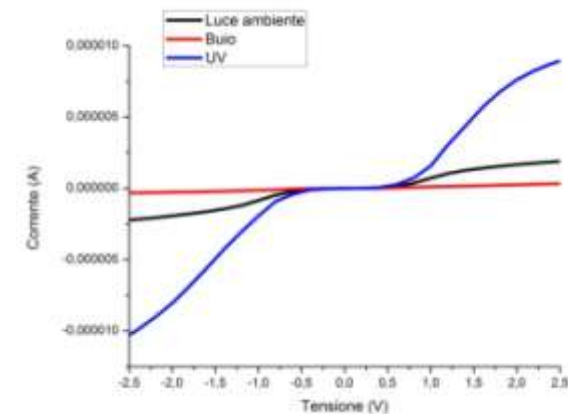
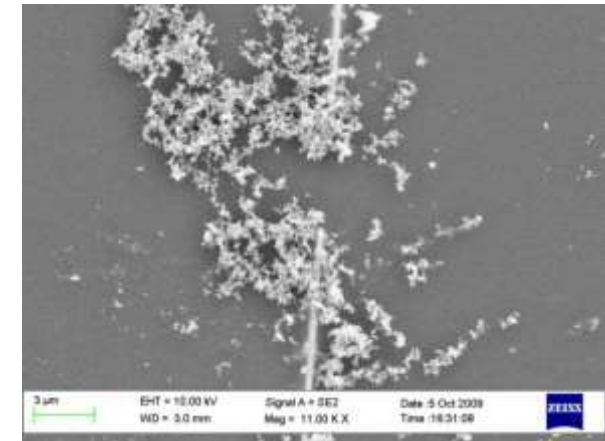


$R = 700 \text{ k}\Omega$

Preliminary results: **capture of thick flakes and not of single-layer graphene.**

Results show that when dielectrophoresis is applied to an organic solvent graphene dispersion only thick flakes are driven towards the electrodes, because **single-layer graphene are present at low concentration** in the solution.

## ZnO-based devices

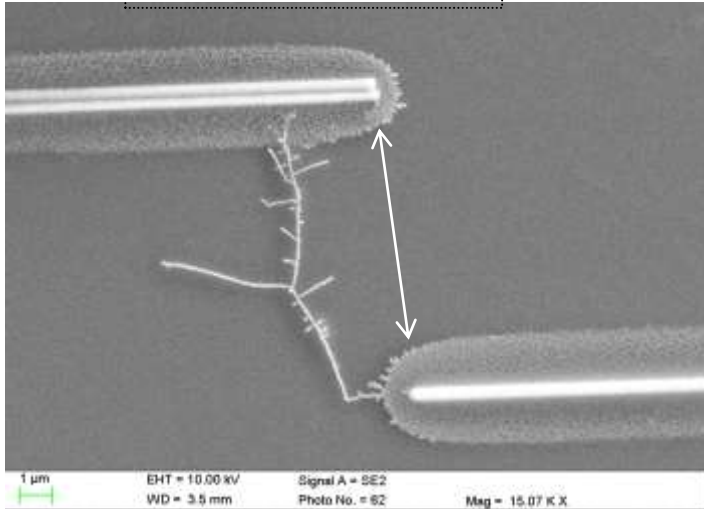




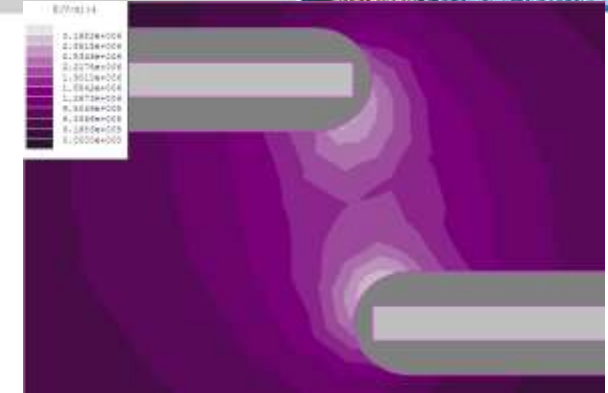
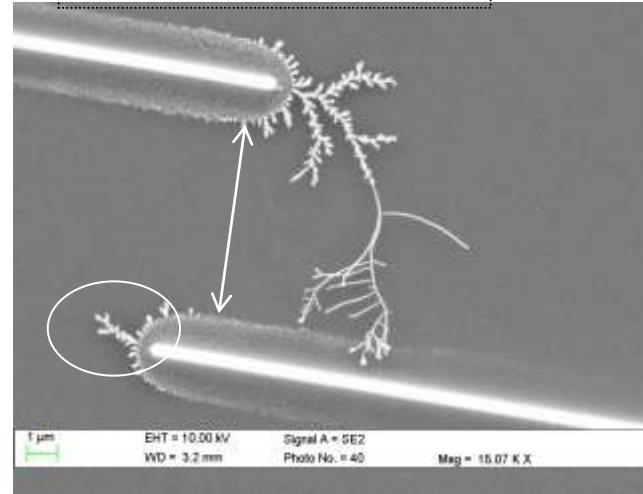
# SENSOR DEVICE: SINGLE PALLADIUM NANOWIRE

electrode geometry influences the nanowire growth: fixing the frequency at 300kHz

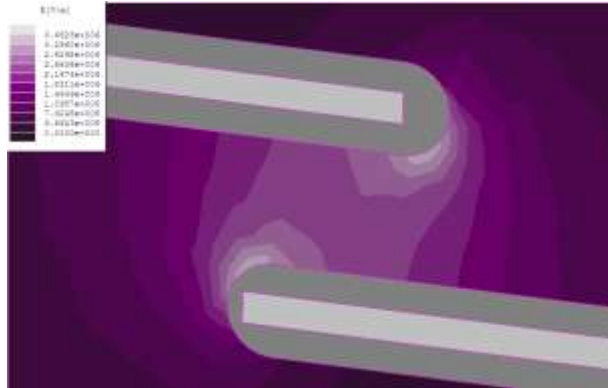
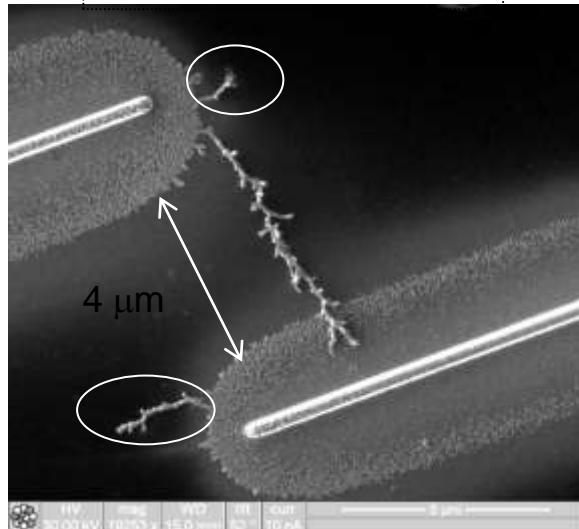
No overlapping  
Gap 7  $\mu\text{m}$



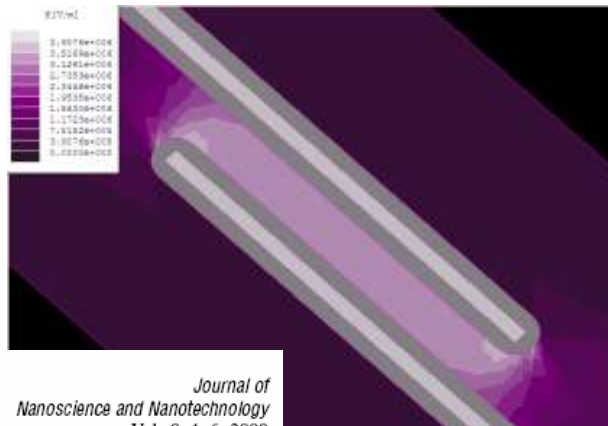
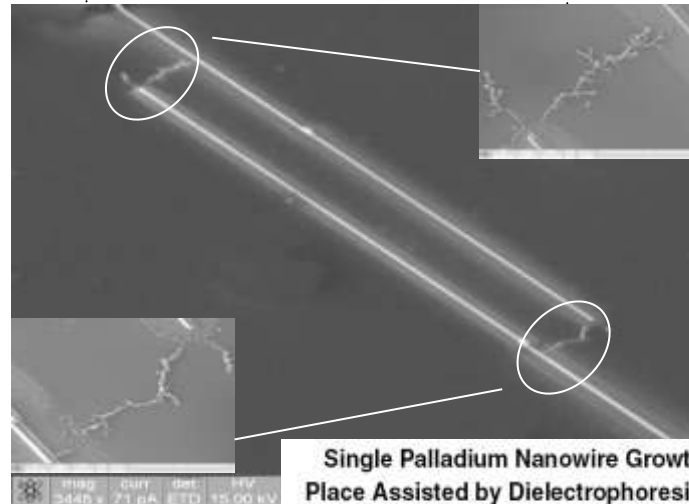
overlapping 3  $\mu\text{m}$   
Gap 7  $\mu\text{m}$



overlapping 2  $\mu\text{m}$   
Gap 4  $\mu\text{m}$



overlapping 100  $\mu\text{m}$   
Gap 6  $\mu\text{m}$



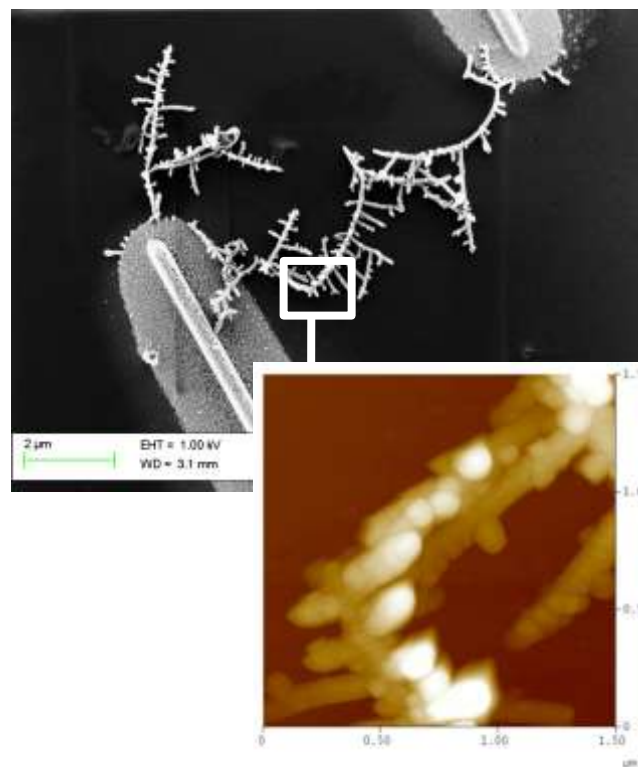
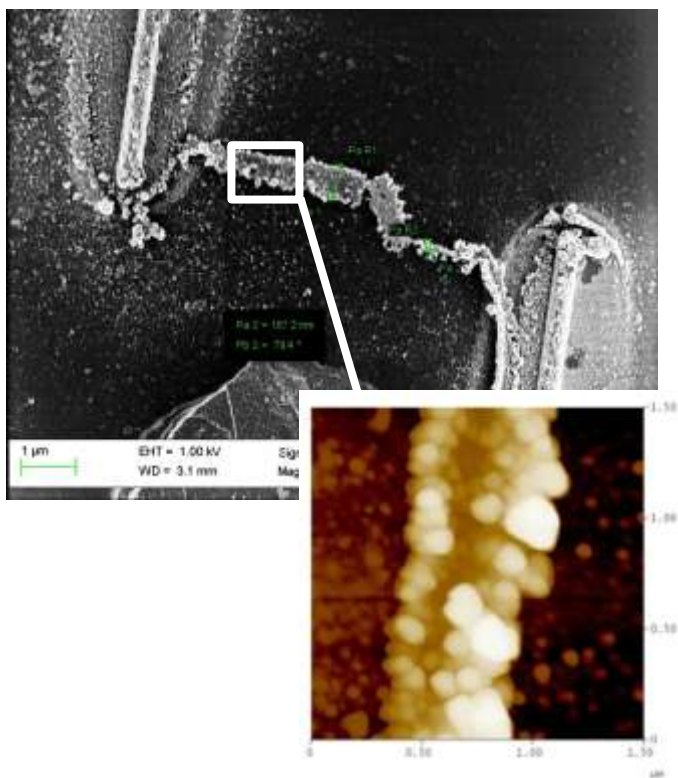
Single Palladium Nanowire Growth in Place Assisted by Dielectrophoresis and Focused Ion Beam

*Journal of Nanoscience and Nanotechnology*  
Vol. 9, 1-6, 2009

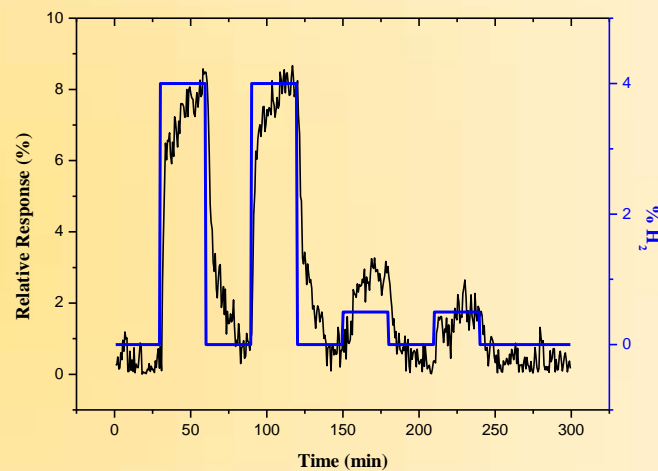
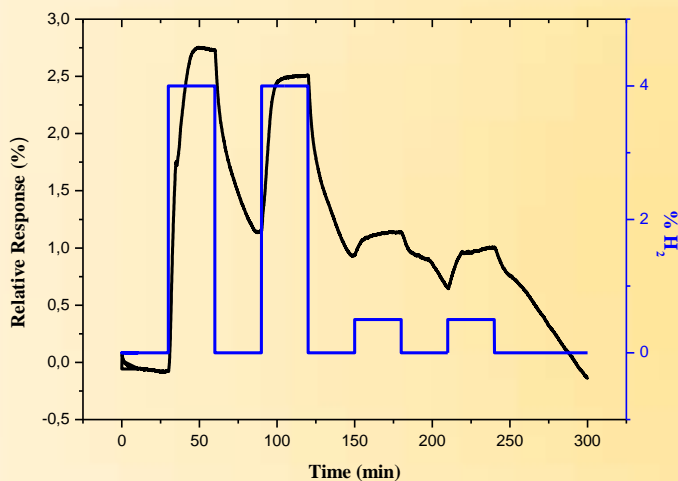


# Single Pd Nanowire based HYDROGEN sensor

Frequency influences the nanowire growth: fixing the electrode pattern



- compact grain structure
- overlaid layers
- Grain diameter ranging from 30 to 100 nm.



## PROCEDURE

- i) One/two **platinum nanoelectrodes** have been deposited by **FIB** and **eventually milled for nanogap**
- ii) **nanoparticles solution** is dropped between nanoelectrodes;
- iii) an **alternating electric field (DEP)**, conducts to **single nanowire or nanostructures assembly**

- **DEP is versatile technique controlling nanowire length, diameter and position**

- **FIB process is a direct-write method to realize nanopatterned electrodes**

- **single palladium nanowire based device operating as Hydrogen sensor at RT**

- **Preliminary results on graphene and ZnO**